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OGOSH25USA

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

#4/B

In re the Application of:)	
)	Examiner:
Yuichiro Shindo et al.)	
)	Group Art Unit:
Application No.:)	
)	
Corresponding International Filing No.:)	
PCT/JP2003/010251)	
)	
Filed: Herewith)	
)	
For: HIGH PURITY COPPER)	
SULFATE AND METHOD)	
FOR PRODUCTION THEREOF)	

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Commissioner for Patents
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Alexandria, VA 22313-1450

SECOND PRELIMINARY AMENDMENT

Sir:

Please amend the above-identified patent application as follows.

Amendments to the Specification begin on page two of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page three of this paper.

Remarks begin on page seven of this paper.